

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

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|---|---|---|------------------|------------------|-----------|
| Applicant Yoshitaka TSUNASHIMA et al. | | | | | |
| Filing Date October 13, 2000 | | | Group | Not yet assigned | |
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| Examiner <i>Q</i> | Date Considered <i>April 6, 2007</i> | | | | |
| *Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | |
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